DO NOT ENTER

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 6998

Hidehiko SHIN et al.

Attorney Docket No. 2006_1397A

Serial No. 10/590,339

Group Art Unit 2175

Filed August 23, 2006

Examiner Jinhee J. Lee

DISPLAY PROCESS DEVICE AND DISPLAY PROCESS METHOD

Mail Stop: AF

RESPONSE UNDER 37. CFR116

EXPEDITE PROCEDURE EXAMINING GROUP 2100

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action of November 25, 2008, please amend the above-identified application as follows:

J2409